



Atty. Dkt. No. 044499-0206

DAN

PATENT & TRADEMARK OFFICE THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kiyoshi MURAKAMI

Title: SUBSTRATE INSPECTING METHOD AND SUBSTRATE
INSPECTING APPARATUS USING THE METHOD

Application No.: 10/786,468

Filing Date: 02/26/2004

Examiner: Arbes, Carl J.

Art Unit: 3729

Allowed Date: 04/24/2006

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.312

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is being filed after receipt of a Notice of Allowance dated April 24, 2006, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 7 of this document.

Please amend the application as follows: